

Title (en)  
CONTINUOUS FLOW SYSTEM AND METHOD FOR COATING SUBSTRATES

Title (de)  
DURCHLAUFANLAGE UND VERFAHREN ZUM BESCHICHTEN VON SUBSTRATEN

Title (fr)  
INSTALLATION À FLUX CONTINU ET PROCÉDÉ DE REVÊTEMENT DE SUBSTRATS

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Application  
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Abstract (en)  
[origin: WO2019219292A2] The invention relates to a continuous flow system (100) for coating substrates (103) comprising a treatment module (130) and a vacuum sluice (110, 150) for introducing the substrates (103) or for discharging the substrates (103). The vacuum sluice (110, 150) has a chamber for receiving a substrate carrier (102) having a plurality of substrates (103) and a flow channel arrangement for evacuating and flooding the chamber. The flow channel arrangement comprises a first channel for evacuating and flooding the chamber and a second channel for evacuating and flooding the chamber, wherein the first channel and the second channel are arranged on opposite sides of the chamber.

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